## DEGREE AUDIT

FOR

## CDT CHEME1 - USMA ID: CXXXXXXXX - CLASS: 2020

## Date: 06/04/2020 - Time: 01:46:40PM

## Refresh Page

MAJOR	TRACK		MAJ CRSE	MAJ CRSE TITLE	SATISFIED?	CMPLTD CRSE	SBST CRSE	ACAD YR	TERM
N1	Required Courses (12 of 12)				Y				
		1	CH362	MASS & ENERGY BALANCES		CH362		2018	2
		2	CH363	SEPARATION PROCESSES		CH363		2019	1
		3	CH364	CHEMICAL REACTION ENGINEERING		CH364		2019	2
		4	CH365	CHEMICAL ENG THERMODYNAMICS		CH365		2020	1
		5	CH367	INTRO / AUTOMATIC PROC CONTROL		CH367		2019	2
		6	CH383	ORGANIC CHEMISTRY I		CH383		2019	1
		7	CH400	CHEM ENG PROFESSIONAL PRACTICE		CH400		2020	2
		8	CH459	CHEM ENGR LABORATORY		CH459		2020	1
		9	CH485	HEAT AND MASS TRANSFER		CH485		2020	1
		10	MC300	FUND OF ENGR MECH AND DESIGN		MC300		2019	2
		11	MC311	THERMAL-FLUID SYSTEMS I		MC311		2019	1
		12	MC312	THERMAL-FLUID SYSTEMS II		MC312		2019	2
	Electives (3 of 17)				Υ				
		1	EE360	DIGITAL LOGIC W/ EMBEDDED SYS					
		2	EE377	ELECTRICAL POWER ENGNRNG					<del>                                     </del>
		3	EM411	PROJECT MANAGEMENT		EM411		2020	2
		4	EM420	PRODUCTION OPERATIONS MGMT		EM420		2020	1
		5	EM481	SYSTEMS SIMULATION					╁
		6	MC306	DYNAMICS					<del>                                     </del>
		7	MC364	MECHANICS OF MATERIALS					$\vdash$
		8	MC380	ENGINEERING MATERIALS					+
		9	ME472	ENERGY CONVERSION SYSTEMS					₩
		Ť							├
		10	ME480	HEAT TRANSFER					₩
		11	ME491	MECHANICAL POWER PLANTS					-
		12	NE300	FUNDAMENTALS OF NUCLEAR ENGR					₩
		13	NE350	RADIOLOGICAL ENGR DESIGN					₩
		14	NE450	NUCLEAR WEAPONS EFFECTS					<u> </u>
		15	SE301	FNDTN ENGIN DSGN & SYS MGMT		SE301		2020	1
		16	SM484	SYSTEM DYNAMICS SIMULATION					<u> </u>
		17	XE475	MECHATRONICS					
	Complementary Support Courses (3 of 5)				Y				
		1	EE301	FUNDAMENTALS OF ELEC ENGIN		EE301		2019	1
		2	MA364	ENGINEERING MATHEMATICS		MA364		2019	1
		3	MA365	ADV MATH FOR ENGRS/SCIENTISTS					
		4	PH206	PHYSICS II		PH206		2018	2
		5	PH256	ADVANCED PHYSICS II					
	Integrative Experience for the Major (1 of 1)				Y				
		1	CH402	CHEM ENG PROCESS DESIGN		CH402		2020	2
	Science Depth (0 of 0)				Y				
		1	CH102	GENERAL CHEMISTRY II		CH102		2018	1
	STEM Depth (0 of 0)				Y				
		1	MA205	CALCULUS II		MA205		2018	2
		2	MA255	ADV MULTIVARIABLE CALCULUS					
	IT/CYBER Requirement (0 of 0)				Y				
		1	CH367	INTRO / AUTOMATIC PROC CONTROL		CH367		2019	2
		2	EE301	FUNDAMENTALS OF ELEC ENGIN		EE301		2019	1
	Writing-in-the-Major (0 of 0)				Υ				
		1	MC312	THERMAL-FLUID SYSTEMS II		MC312		2019	2